

IFW



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80400

Masato KOBAYAKAWA, et al.

Appln. No.: 10/591,584

Group Art Unit: 2811

Confirmation No.: 3381

Examiner: Not Yet Assigned

Filed: November 27, 2006

For: GALLIUM NITRIDE-BASED SEMICONDUCTOR DEVICE

**SECOND PRELIMINARY AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination, and following entry of the Preliminary Amendment filed September 5, 2006, please amend the above-identified application as follows on the accompanying pages.

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